

Semiconductor Workpiece Process Fluid

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 5 2 05

Rv'

James D. Shaurette

Reg. No. 39,833

Ey549572016

Form PCO-1449 O 1 P E MAY 0 3 2015 2

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. MI22-1246 SERIAL NO. 09/517,127

LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)

APPLICANT Scott E. Moore et al.

FILING DATE March 12, 2000 GROUP 3724

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,096,185	8/1/2000	Corlett et al.			
	AB	5,791,970	8/11/1998	Yueh			
	AC	4,282,745	8/1981	Burr, Kenneth J.			
	AD	4,457,624	7/1984	Goldberg et al.		;	
	AE	5,194,921	3/1993	Tambo et al.			
	AF	3,695,763	10/1972	Shiuh, Jerome			
	AG	5,750,440	5/1998	Vanell et al.			
	АН						
	AI						
_	AJ						
	AK	ii.					
	AL						

FOREIGN PATENT DOCUMENTS Document Number Date Country Class Subcla Translation Yes No AM

OTHER REFERENCES	(including Author	r, Title, Date,	Pertinent	Pages, 1	Etc.)	١
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EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.